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Attorney Docket No. 0756-2417

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 10/034,498

Filed: January 3, 2002

For: METHOD OF MAKING A THIN FILM  
TRANSISTOR USING LASER  
ANNEALING (AS AMENDED)

) Group Art Unit: 2824

) Examiner: B. Smith

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is being  
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) April 5, 2004.

) Achille M. Stamps

**AMENDMENT**

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated December 4, 2003, please consider the following amendments and remarks in connection with the above-identified application.

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Amendments to the Drawings** begin on page 19 of this paper and include an attached replacement sheet.

**Remarks** begin on page 20 of this paper.